



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 21, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG819698296

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.80 x 9.32 x 5.65 mm

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

EXCELLENT

EXCELLENT

NONE

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

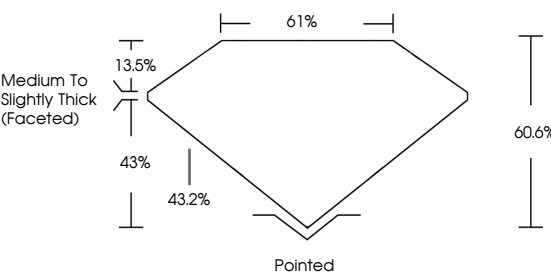
IGI LG819698296

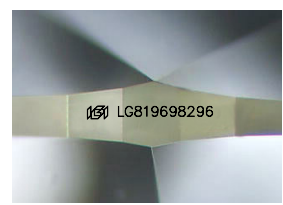
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG819698296

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS





Sample Image Used

LIGHT PERFORMANCE REPORT

Light Performance Grade: Exceptional



Structured Light Environment Representation

ModerateHighSuperiorExceptional

Light Performance

Brightness

Fire

Contrast

COLOR

D E F G H I J FaintVery LightLight

CLARITY

FL IF VS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.80 X 9.32 X 5.65 MM

EXCELLENT

4.49 CARATS

D

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

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EXCELLENT

EXCELLENT

NONE

IGI LG819698296

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IGI

July 21, 2026

IGI Report No LG819698296

OVAL BRILLIANT

13.80 X 9.32 X 5.65 MM

Carat Weight

Color Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

4.49 CARATS

D

VS 1

60.6%

61%

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG819698296

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